



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Menon et al. GROUP: 2881
SERIAL NO: 10/624,316 EXAMINER: Jack I. Berman
FILED: 7/21/03 Date of mailing
of Notice of
Allowance: 6/1/05
FOR: SYSTEM AND METHOD FOR MASKLESS
LITHOGRAPHY USING AN ARRAY OF
IMPROVED DIFFRACTIVE FOCUSING
ELEMENTS


Mail Stop Issue Fee
Assistant Commissioner of Patents
P.O. Box 1450, Alexandria, VA 22313-1450
Attn: Official Draftsman

TRANSMITTAL OF FORMAL DRAWINGS

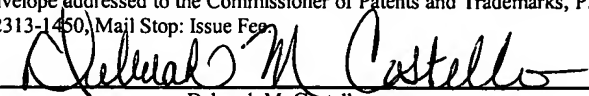
Applicant submits herewith new drawing(s) for this application. Attached please find ten (10) sheets of formal drawings for this application.

The three month period of response set in the Notice of Allowability (PTOL 37) expires on September 1, 2005, and this submission is on or before this expiry date.

Respectfully submitted,

for  35192
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I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the Commissioner of Patents and Trademarks, P.O. Box 1450, Alexandria, VA 22313-1450, Mail Stop: Issue Fee


Deborah M. Costello

Date: 8-26-05